

Attorney Docket No. P30916

Application No.: 10/599,576

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Sakae KOYATA et al.

Group Art Unit: 1713

Appln. No. : 10/599,576  
(U.S. National Phase of PCT/JP2005/005527)

Examiner: Lan Vinh

I.A. Filed : March 25, 2005

Confirmation No.: 1978

For : ALKALINE ETCHANT FOR CONTROLLING SURFACE ROUGHNESS OF  
SEMICONDUCTOR WAFER

**RESPONSE UNDER 37 C.F.R. § 1.111**

Commissioner for Patents  
U.S. Patent and Trademark Office  
Customer Service Window, Mail Stop Amendment  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314

Sir:

This Amendment is responsive to the Official Action of the U.S. Patent and Trademark Office dated May 25, 2010. Inasmuch as this response is filed by August 25, 2010, no extension of time is required. However, if the Office deems any extension of time to be required, Applicants expressly authorize the charging of such fee to Deposit Account 19-0089.

Please amend the application as follows:

**Amendments to the Claims** are reflected in the listing of claims, which begins on page 2 of this paper; and

**Remarks** begin on page 4.